



Applicants:

Eran Dvir, Moshe Finarov, Eli Haimovich, and Benjamin Shulman

Assignee:

Nova Measuring Instrument, Ltd.

Title:

APPARATUS FOR OPTICAL INSPECTION OF WAFERS DURING

**POLISHING** 

Serial No.:

08/497,382

Filed:

June 29, 1995

Examiner:

E. Morgan

Group Art Unit:

3203

Docket No.:

M-3417 US

San Jose, California October 2, 1997

COMMISSIONER OF PATENTS AND TRADEMARKS Washington, D. C. 20231

## **AMENDMENT**

Dear Sir:

In response to the Official Action mailed June 3, 1997, kindly amend the above identified application as follows:

## IN THE SPECIFICATION

Page 3, line 16, kindly delete "or water".

IN THE CLAIMS

Kindly cancel claims 1-4, 6-8, 10, 14 and 16.

LAW OFFICES OF SKJERVEN, MORRILL, MacPHERSON, FRANKLIN & FRIEL LLP

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